# PROCEEDINGS OF SPIE

## AOPC 2022: Novel Optical Design; and Optics Ultra Precision Manufacturing and Testing

Lingbao Kong Dawei Zhang Zexin Feng Editors

#### 18–19 December 2022 ONLINE, China

Sponsored by Chinese Society for Optical Engineering (CSOE) (China)

Technical Sponsor SPIE

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Published by SPIE

Volume 12559

Proceedings of SPIE 0277-786X, V. 12559

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ISSN: 0277-786X ISSN: 1996-756X (electronic)

ISBN: 9781510662322 ISBN: 9781510662339 (electronic)

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